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Docket No.: 2729-162

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Inventor(s): Hew Nam AHN et al. et al. : Confirmation No.3742
U.S. Patent Application No. 10/648,250 : Group Art Unit: 3744
Filed: August 27, 2003 : Examiner: WILLIAM E. TAPOLCAI
For: COMPRESSOR

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of the first Office Action on the merits, but before the mailing date of the Final Rejection or Notice of Allowance.

CERTIFICATION PARAGRAPH

The undersigned hereby certifies that each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent

office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement (37 CFR 1.97 (e)(1)). A copy of the foreign search report is enclosed for the Examiner's information.

Respectfully submitted,

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Date: August 3, 2004

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|---|--------------|--|----------------|--|----------|----------------|----|
| <div>TYPE INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)</div> <div>U.S. PATENT DOCUMENTS</div> | | ATTY. DOCKET NO. 2729-162 | | U.S. PATENT APPLICATION NO. 10/648,250 | | | |
| | | APPLICANT Hew Nam AHN et al. et al. | | | | | |
| | | FILING DATE August 27, 2003 | | GROUP 3744 | | | |
| U.S. PATENT DOCUMENTS | | | | | | | |
| EXAMINER'S INITIALS | PATENT NO. | DATE | NAME | CLASS | SUBCLASS | FILING DATE | |
| | 5,112,198 | 5/1992 | Skinner | | | | |
| | 5,507,627 | 4/1996 | Okazaki | | | | |
| | 5,556,260 | 9/1996 | Takenaka et al | | | | |
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| FOREIGN PATENT DOCUMENTS | | | | | | | |
| EXAMINER'S INITIALS | PATENT NO. | DATE | COUNTRY | CLASS | SUBCLASS | Translation | |
| | | | | | | Yes | No |
| | 0 911 519 A2 | 4/1999 | EP | | | | |
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| OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | | |
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| EXAMINER | | | | DATE CONSIDERED | | | |

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.